



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tan et al.

Serial No.: 10/645,389

Filed: August 21, 2003

For: METHODS RELATING TO THE
RECONSTRUCTION OF
SEMICONDUCTOR WAFERS FOR
WAFER-LEVEL PROCESSING (as
amended)

Confirmation No.: 8099

Examiner: W. Brewster

Group Art Unit: 2823

Attorney Docket No.: 2269-5528US
(02-1052.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

11/28/2005
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Erika Gandre
Name (Type/Print)

AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed September 27, 2005, the three-month shortened statutory period for response to which expires on December 27, 2005. This response is submitted on or before two months from the mailing date of the Final Office Action on November 28, 2005, November 27th being a Sunday.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

OK to Enter

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